



IFW 1722

PATENT
03345-P0017A WWW/DWA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Michael Heuken, <i>et al.</i>
Application No. 09/873,041	Filing Date: June 1, 2001
Title of Application:	Method And System For Semiconductor Crystal Production With Temperature Management
Confirmation No. 5097	Art Unit: 1722

Mail Stop Issue Fee
Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Notice Of Allowance - Examiner's Detailed Action: Priority

Further to the Examiner's Remarks on Page 2 of the Notice of Allowability re the Certified copy of DE 19855637.3, Applicants respectfully submit that a copy of the priority document is not necessary as it was filed with WIPO.

Respectfully submitted,

July 11, 2006

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July 11, 2006

Beatrice R. Emerson



FW

URGENT !

Date 7/10/2006

To: Commisioner of patents

Re: Patent office inaction

This is to notify the patent office that I have not heard anything from them for my patent application **11/143048** that was submitted on **June 1, 2005** and verified received by your office stamp on **June 2, 2005**

Please provide status.

Thank You,

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